In place of PTO-1449 Form	U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT *(use as many sheets as necessary)*				Application Number	10/625,432
				Filing Date	July 23, 2004
				Applicant(s)	Birgie Kuo
				Art Unit	TBD
				Examiner Name	TBD
SHEET	1	OF	1	Attorney Docket Number	24061.100

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U. S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	Document Number	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant of Cited Document
ABR	AA	6,537,844	03-25-2003	Itoh

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Cite No.	Foreign Patent Document (Country Code – Number – Kind)	Publication Date (MM-DD-YYYY)	Patentee or Applicant of Cited Document	Translation (Y/N)

OTHER PRIOR ART

Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
ABR	AB	Kuo, Birgie, "Enterprise Mask Process Management", MIT e-Operations Symposium, Taiwan Semiconductor Manufacturing Co., Ltd. Manufacturing Information Technology Division (TSMC MITD), June 2003, 10 pages.

Examiner Signature		Date Considered	11/1/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

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